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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant(s):** Kwang Su Choe, et al.

**Docket:** YOR920030293US1 (16818)

**Serial No:** ~~To be assigned~~  
10/674,647

**Date:**

**Filed:** ~~Herewith~~ 9/30/2003

**For:** THIN BURIED OXIDES BY LOW-DOSE  
OXYGEN IMPLANTATION INTO MODIFIED SILICON

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**ASSOCIATE POWER OF ATTORNEY AND  
REQUEST FOR CHANGE OF MAILING ADDRESS**

Sir:

Applicant(s), by (his/her/their) attorneys of record, hereby grant(s) an Associate Power of Attorney to:

FRANK S. DIGIGLIO, Reg. 31,346; LEOPOLD PRESSER, Reg. No. 19,827; STEVEN FISCHMAN, Reg. No. 34,594; JOHN S. SENSNY, Reg. No. 28,757; EDWARD W. GROLZ, Reg. No. 33,705; and WILLIAM C. ROCH, Reg. No. 24,972.

with full power of substitution to prosecute this application and transact all business in the United States Patent and Trademark Office in connection therewith.

Applicant(s) further request(s) that all future correspondence in connection with this application be directed and addressed to:

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